Receipt date: 06/03/2008

10581578 - GAU: 4181

Docket No. 42479-9400

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: December 26, 2006

For: ANION ADSORBING CARBON MATERIAL,

AS WELL AS MANUFACTURING METHOD AND MANUFACTURING FACILITIES FOR

SAME

Group Art Unit: 1793

Confirmation No.: 4920

June 3, 2008

Costa Mesa, California 92626

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following reference which was found during the prosecution of a co-pending Chinese patent application:

Chinese Publication No. 1040185A w/English translation of claims.

A copy of the reference and Form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

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If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER L.L.P.

Joseph W. Price, Reg. No. 25,124 600 Anton Boulevard, Suite 1400 Costa Mesa, CA 92626-7689

Tel: 714-427-7420 Fax: 714-427-7799

Receipt date: 06/03/2008 INFORMATION DISCLOSURE CITATION				Docket Number (Optional)		Applikation Natition - GAU. 418		
				42479-9400	10/581,578			
				Applicant(s)				
	(Use s	several sheets if necessary)	•	Satoshi Hayashi et al.				
				Filing Date	Group Art Unit 1793			
				December 26, 2006				
***************************************			1	J. S. PATENT DOCUMENTS				
EXAMINER INITIAL	REF DOCUMENT NUMBER		DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
			- n##19*3					
			U.S. PATE	T APPLICATION PUBLICATION	S			
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				Assertation				
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	REF	REF DOCUMENT NUMBER DAT		COUNTRY CLASS		SUBCLASS	Translation YES NO	
		1040185A	3.7.1990	China w/English translation of claims			X	
	,	ОТН	ER DOCUME	NTS (Including Author, Title, Date, Pertinent P	ages, Etc.)			
EXAMINER /Brian Walck/				DATE CONSIDERED 01/31/2009				
EXAMINEI Include copy	R: Initial	if citation considered, whether	er or not citation i to applicant.	s in conformance with MPEP 609; draw line thro	ugh citation	if not in conformat	nce and not	considered.

Form PTO-A820 also form PTO-1449) P09A/REV05

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